

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	12	alternat\$ with (electromachin\$ electropolish\$) with (CMP (chemical adj mechanical adj polish\$))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 11:44
L2	13	alternat\$ with (electromachin\$ electropolish\$ EMP) with (CMP (chemical adj mechanical adj polish\$))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 11:45
L3	24	alternat\$ with (electromachin\$ electropolish\$ electroplanariz\$ (electrochemical adj (machin\$ polish\$ planariz\$)) EMP) with (CMP (chemical adj mechanical adj polish\$))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 15:12
L4	1	serial\$ with (electromachin\$ electropolish\$ electroplanariz\$ (electrochemical adj (machin\$ polish\$ planariz\$)) EMP) with (CMP (chemical adj mechanical adj polish\$))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 11:53
L5	0	series with (electromachin\$ electropolish\$ electroplanariz\$ (electrochemical adj (machin\$ polish\$ planariz\$)) EMP) with (CMP (chemical adj mechanical adj polish\$))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 11:56
L6	310	205/662-663.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 11:56
L7	28	205/662-663.ccls. and alternating	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 15:10
L8	0	205/662-663.ccls. and alternating with ((chemical adj mechanical adj polishing) CMP)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 11:57
L9	2	"20030062269"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 15:10
L10	155	electropolishing with cmp	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 15:27

L11	281	eddy adj current and plasma adj etching	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 15:27
L12	14	eddy adj current with (endpoint (end adj point)) and plasma adj etching	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 15:28
L13	0	eddy adj current with (endpoint (end adj point)) same plasma adj etching	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 15:28
L14	5	downey.in. and plasma adj etching	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 16:36
L15	66	"4358338"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 16:36
L16	2	"4358338".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 16:36